

10/10/2003

*Information Disclosure Statement*

<b>Notice of References Cited</b>	Application/Control No.	Applicant(s)/Patent Under Reexamination TEPPER ET AL.	
	Examiner	Art Unit	Page 1 of 1

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

U.S. Patent and Trademark Office

PTO-892 (Rev. 01-2001)

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PTD 1449

*Tepper*

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